U.S. Application No. 09/976,579 Amdt. dated October 8, 2003 O Porto Office Action of July 8, 2003 In re the application of: Sundar Amartur

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/976,579 Group Art Unit: 2877 Confirmation No.: 2460 Examiner: Geisel, Kara E Filed: October 12, 2001 Atty. Docket No: LAM2P253.CIP2 For: IN-SITU DETECTION OF THIN-METAL Date: October 8, 2003 INTERFACE USING HIGH RESOLUTION SPECTRAL ANALYSIS OF OPTICAL <u>INTERFERENCE</u>

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Signed:

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Applicant submits this paper in response to the Office Action mailed July 8, 2063. Please amend this application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.

Dear Sir: